



EL 979978135

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. .... 10/071,425  
Filing Date ..... February 8, 2002  
Inventor ..... Terry L. Gilton et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Thanhha S. Pham  
Attorney Docket No. .... MI22-1828  
Customer No. .... 021567  
Title: Semiconductor Processing Method Using Photoresist and an Antireflective  
Coating

**INFORMATION DISCLOSURE STATEMENT**

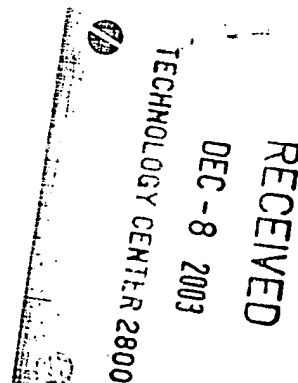
References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 11-21-03By: 

Mark S. Matkin  
Reg. No. 32,268



Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
MI22-1828

SERIAL NO.  
10/071,425

LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)

APPLICANT: Terry L. Gilton et al.

FILING DATE  
February 8, 2002

GROUP  
2813

U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,127,414	11/28/78	Yoshikawa et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM		
	AN		
	AO		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.